In re Application of:	Kim, et al.
Application No.:	10/632,873
Filing Date:	August 1, 2003
Title:	SELECTIVE ETCHING OF CARBON- DOPED LOW-K DIELECTRICS
Direct to:	Mail Stop Reconsideration Commissioner for Patents United States Patent and Trademark Office Alexandria, VA 22313-1450
NOTICE UNDER 37 C.F	F.R. §1.251 – PENDING APPLICATION
Statement (check the appropriate box	x):
the correspondence between the Office and	is a complete and accurate copy of Applicant's record of all of the Applicant for the above-identified application (except for not aware of any correspondence between the Office and on that is not along Applicant's records.
☐ The copy of the paper(s) listed in to copy of Applicant's record of such paper(s).	he notice under 37 C.F.R. §1.251 is/are a complete and accurate
between the Office and the Applicant f	t are Applicant's complete record of all of the correspondence for the above-identified application (except for U.S. patent any correspondence between the Office and the Applicant for mong Applicant's records.
☐ Applicant does not possess any rec for the above-identified application.	ord of the correspondence between the Office and the Applicant
Sept. 27, 2004	Signature
	Keith Taboada, Attorney Reg. No. 45,150 Moser, Patterson & Sheridan, LLP 595 Shrewsbury Avenue Suite 100 Shrewsbury, NJ 07702 (732) 530-9404

A copy of this notice should be returned with the reply.